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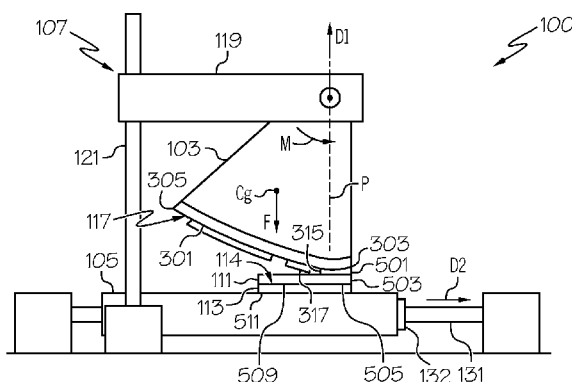


FIG. 5

(57) **Abstract:** A peeling apparatus (100) includes a peeling member (103) with an attachment member (115) including an arcuate surface (117) and configured to releasably mount a first substrate (111) with respect to the arcuate surface. The peeling apparatus further includes a translation mechanism (107) configured to translate a support axis (X) relative to a second substrate (113) to move the peeling member away from the second substrate while the peeling member rotates about the support axis. In further examples, methods include releasably mounting a first substrate with respect to an arcuate surface of a peeling member and releasably mounting a second substrate relative to a support location (105). The method further includes translating a support axis of the peeling member relative to the second substrate to move the peeling member away from the second substrate, wherein the first substrate peels from the second substrate as the peeling member rotates about the support axis.